

AF/2834  
PATENT  
930055-2031

U.S. Patent Application No. 10/518,704  
Response to Office Action mailed May 18, 2007




**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Tetsuo YAMADA, et al.  
Serial No. : 10/518,704  
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN  
FILM PIEZOELECTRIC DEVICE, AND  
MANUFACTURING METHOD THEREOF (As Amended)  
Filing Date : December 17, 2004  
Examiner : Mark Osborne Budd  
Group Art Unit : 2834  
Confirmation No. : 5674

745 Fifth Avenue  
New York, NY 10151  
(212) 588-0800

I hereby certify that this correspondence is being deposited with  
the United States Postal Service as first class mail in an envelope  
addressed to: Mail Stop Amendment, Commissioner for  
Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on  
June 14, 2007.

Ronald R. Santucci, Reg. No. 28,988  
(Name of Applicant, Assignee or Registered Representative)  
  
Signature  
June 14, 2007  
Date of Signature

**AMENDMENT**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 18, 2007, setting a two-month period  
for response ending July 18, 2007, Applicants respectfully request that the application be further  
amended as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 17 of this paper.